

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#5/c

In re Application

Inventor(s):

Stephen P. DeOrnellas et al.

SC/Serial No.: 10/045,318

Confirm. No.:

3120

Filed:

November 9, 2001

Title: METHOD FOR USING A HARD MASK

FOR CRITICAL DIMENSION GROWTH

CONTAINMENT

PATENT APPLICATION

Art Unit:

1765

Examiner: L. Umez-Eronini

Customer No. 23910

(Attorney Signature)

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents Washington, DC 20231, on to Commissioner for Patents, Washington, DC 20231, on _

Jason D. Lohr, Reg Signature Date:

RESPONSE [A] TO OFFICE ACTION UNDER 37 C.F.R. § 1.111

Commissioner for Patents Washington, DC 20231

Sir:

This RESPONSE [A] is in reply to the Office action mailed May 22, 2002. No fee is due for the addition of new claims.

Amendments

Please amend the above-identified application as follows:

In the Claims:

Please amend claim 1 and add new claims 51-56, all as shown below.

All pending claims are reproduced below, including those that remain unchanged. Marked up copies of the amended claims illustrating the changes are shown in the Appendix to this Response.

- 1 -